# **INTERNATIONAL STANDARD**



First edition 2022-07

# s f Surface chemical analysis — Atomic force microscopy — Guideline for restoration procedure for atomic force microscopy images dilated by finite probe size

Analyse chimique des surfaces — Microscopie à force atomique — Lignes directrices relatives au mode opératoire de restauration des images de microscopie à force atomique dilatées par la taille finie de la sonde

Reference number ISO 23729:2022(E)



© ISO 2022

All rights reserved. Unless otherwise specified, or required in the context of its implementation, no part of this publication may be reproduced or utilized otherwise in any form or by any means, electronic or mechanical, including photocopying, or posting on the internet or an intranet, without prior written permission. Permission can be requested from either ISO at the address below or ISO's member body in the country of the requester.

ISO copyright office CP 401 • Ch. de Blandonnet 8 CH-1214 Vernier, Geneva Phone: +41 22 749 01 11 Email: copyright@iso.org Website: www.iso.org

Published in Switzerland

Page

# Contents

Foreword			iv
Intro	oductio	)n	v
1	Scop	e	
2	Normative references		
3	Terms and definitions		
4	Symbols (and abbreviated terms)		
5	Matl	hematical morphology modelling	
6		cedure of restoration of AFM topography images   General   Calibration of measuring systems   Environment requirements   Extraction of probe tip shape using certified reference materials   Estimation of probe tip shape by blind reconstruction   Reference materials   Probe shape characteristic and curvature radius   Validity test for topography image restoration	4 4 5 5 5 6 6 6
Anno	ex A (in	iformative) Example studies	7
Ann	ex B (in	formative) Results of interlaboratory comparison	
Bibliography			

# Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see <a href="https://www.iso.org/directives">www.iso.org/directives</a>).

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. ISO shall not be held responsible for identifying any or all such patent rights. Details of any patent rights identified during the development of the document will be in the Introduction and/or on the ISO list of patent declarations received (see <a href="https://www.iso.org/patents">www.iso.org/patents</a>).

Any trade name used in this document is information given for the convenience of users and does not constitute an endorsement.

For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT), see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 201, *Surface chemical analysis*, Subcommittee SC 9, *Scanning probe microscopy*.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at <u>www.iso.org/members.html</u>.

# Introduction

Atomic force microscope (AFM) is a method for imaging surfaces by mechanically scanning their surface contours, in which the deflection of a sharp probe tip sensing the surface forces, mounted on a compliant cantilever, is monitored. AFM belongs to a family of scanning probe microscope (SPM) and is of increasing importance for the characterization of materials surfaces at the nanoscale. Therefore, precise and quantitative measurement of three-dimensional (3D) surface topography at the nanoscale by AFM is highly demanded by researchers and engineers in the various fields of academia and industry. One of the imaging artefacts of AFM topography measurements is caused by the finite size and shape at the apex of an AFM probe used for the scanning. Such a dilation effect due to the probe shape can cause a significant error in the precise analysis of 3D surface morphology. Especially for the critical dimension (CD) analysis of fine devices at the nanoscale, there is a need for probe-shape artefact to be corrected in a reproducible and quantitative way. Thus, the demand for the establishment of an international standard on the guideline for a reliable restoration procedure of dilated AFM images is high.

This document describes a quantitative procedure for the restoration of AFM height images dilated by finite probe size and shape. It includes the quantitative characterization of AFM probe apex in use and the restoration of AFM topography images using the actual probe shape. a BORNIGNORAL CORVIENS ORNALISER ORN

this document is a preview demendence of the document is a preview demendence of the document of the document

# Surface chemical analysis — Atomic force microscopy — Guideline for restoration procedure for atomic force microscopy images dilated by finite probe size

### 1 Scope

This document describes a procedure for the quantitative characterization of the probe tip of an atomic force microscope (AFM) probe and a restoration of AFM topography images dilated by finite probe size. The three-dimensional shape of the probe apex is extracted by image reconstruction using suitable reference materials. This document is applicable to the reconstruction of AFM topography images of solid material surfaces.

#### 2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO 11775, Surface chemical analysis — Scanning-probe microscopy — Determination of cantilever normal spring constants

ISO 11952, Surface chemical analysis — Scanning-probe microscopy — Determination of geometric quantities using SPM: Calibration of measuring systems

ISO 18115-2, Surface chemical analysis — Vocabulary — Part 2: Terms used in scanning-probe microscopy

#### 3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO 18115-2 and the following apply.

ISO and IEC maintain terminology databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <a href="https://www.iso.org/obp">https://www.iso.org/obp</a>
- IEC Electropedia: available at https://www.electropedia.org/

### 3.1

#### dilation

one of the two basic operators of mathematical morphology, whose basic effect on a binary image is to gradually enlarge the boundaries of regions of foreground pixels

Note 1 to entry: The dilation  $(\bigoplus)$  of a set *A* by a set *B* is defined as follows:

$$A \oplus B = \bigcup_{b \in B} (A + b)$$

Note 2 to entry: By dilation, areas of foreground pixels grow in size while holes within those regions become smaller.